Electronic Filing System (EFS) Data **Electronic Patent Application Submission USPTO Use Only**

EFS ID:

65592

Application ID:

10710737

Title of Invention:

CHEMICAL TREATMENT TO **RETARD DIFFUSION IN A**

SEMICONDUCTOR OVERLAYER

First Named Inventor:

Kevin Chan

Domestic/Foreign Application: Domestic Application

Filing Date:

2004-07-30

Effective Receipt Date:

2004-07-30

Submission Type:

Utility Patent Filing

Filing Type:

new-utility

Confirmation number:

4736

Attorney Docket Number:

FIS920040027

Total Fees Authorized:

954.0

Payment Category:

Deposit Account

Deposit Account Number:

90458

Deposit Account Name:

Todd M. C. Li

RAM Payment Status:

RAM has not been processed

Digital Certificate Holder: cn=Todd M. C. Li,ou=Registered Attorneys,ou=Patent and Trademark

Office,ou=Department of Commerce,o=U.S. Government,c=US

Certificate Message Digest: 6172c25ee6a264846c75d31d46c2e236cc149123

PATENT	APPLICATION	SERIAL	NO.	

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE FEE RECORD SHEET

07/30/2004 HTECKLU1 00000037 090458 10710737

01 FC:1001 02 FC:1202 770.00 DA 144.00 DA

PTO-1556 (5/87)